# Compton based Polarized Positrons Source for ILC

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### ILC Source requirements

Parameter	Symbol	Value	Unit
Positrons per bunch	$n_p$	2×10 <sup>10</sup>	e <sup>+</sup>
Bunches per pulse	N <sub>b</sub>	2820	
Bunch Spacing*	$ au_b$	~300	ns
Pulse rep. rate	$f_{rep}$	5	Hz
Energy	$E_{O}$	5	GeV
Positron Polarization**	$P_p$	~60	%

<sup>\*</sup> The length of the bunch train in ILC is  $2820 \times 300 \text{ns} = 0.85 \text{ ms}$  or 250 km. Bunch spacing has to be reduced in the dumping ring.

<sup>\*\*</sup> Polarization level defines conversion/capture efficiency of polarized  $\gamma$  rays into polarized positrons. 60% level corresponds to ~1.5% efficiency.

#### Polarized Positron Production: Compton Ring Scheme: CO<sub>2</sub> Version (Omori, et al.)

30 CO2 Laser Pulse Stacking Cavities

210 mJ in each cavity, 8 degree crossing to e- beam (collisions in 50 turns + 9.9 msec cooling)x100 Hz ■

 $Ne+ = 2.4 \times 10^8 / bunch$ 280 bunches x 2

4.1 GeV e-Linac Compton Ring (low Q)

4.1 GeV e Storage Ring C = 649 m (2.2µs / turn) 280 bunches x 2

 $Ne- = 6.2 \times 10^{10} / bunch$ 

gamma Ne+/Ny = 1.4% $Ng = 1.8 \times 10^{10}$ 

/turn/bunch (23-29 MeV)

5 GeV et Linac Super Conducting 100 Hz

(3) after stacking, DR has 100 m sec. Then DR damp positrons and send them to Main Linac

 $Ne+ = 2.4 \times 10^{10} / bunch$ 2800 bunches

5 GeV e+ Main Damping Ring

(1) 5 turns of Compton Ring makes 2800 bunches (280 x 2 x 5). 50 turns of Compton Ring (110 μs) makes 10 times of stacking in each bucket in DR. Population reaches  $Ne+ = 2.4 \times 10^9 / bunch.$ 

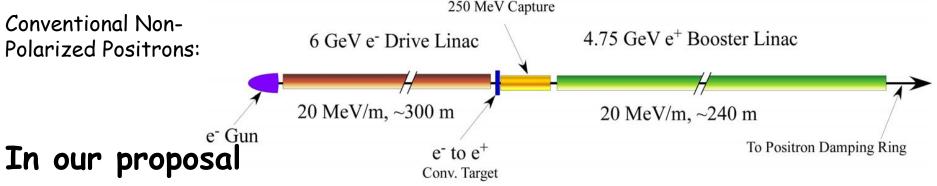
Then 9.9 msec wait for damping.

(2) repeat this 10 times

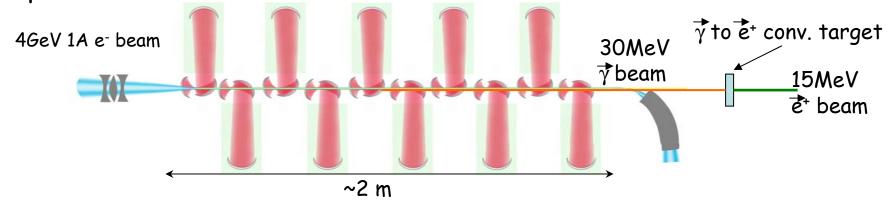
 $Ne+ = 2.4 \times 10^{10} \text{ bunch}$ takes 100 m sec

= 3247 m

#### Polarized Positrons Source (PPS for ILC)



- polarized  $\gamma$ -ray beam is generated in the Compton back scattering inside optical cavity of  $CO_2$  laser beam and 4 GeV e-beam produced by linac.
- The required intensities of polarized positrons are obtained due to 10 times increase of the e-beam charge (compared to non polarized case) and 5 to 10  $CO_2$  laser system IPs.
- Laser system relies on the commercially available lasers but need R&D for the new mode of operation
- 5ps 10J@0.05 Hz CO2 laser is operated at ATF



### Choice of parameters

$$N_{\vec{\gamma}} = \frac{N_e N_{\vec{\varphi}}}{S} \sigma_C$$

 $N_{\gamma}, N_{e}$  and  $N_{\phi}$  are the numbers of  $\gamma$ -rays, electrons and laser photons, S is the area of the interacting beams and  $\sigma_{\mathcal{C}}$  is the Compton cross sections

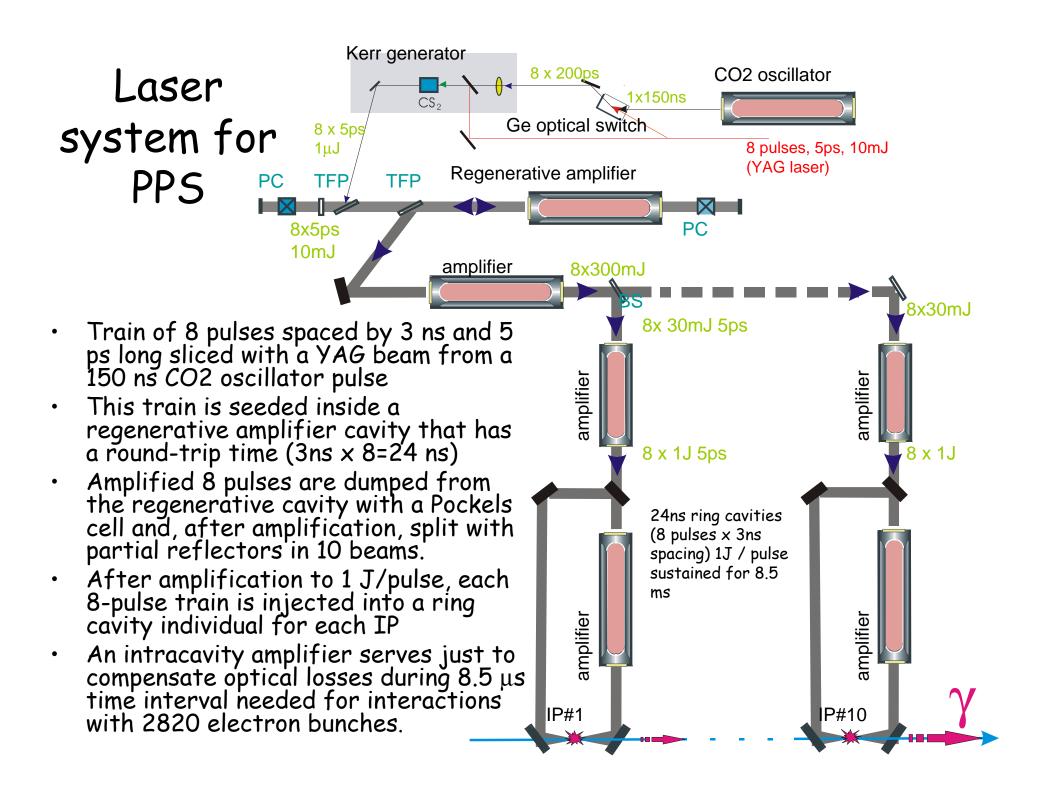
- ~40  $\mu m$  laser focus is set by practical considerations of electron and laser beams focusing and requires ~5 ps long laser pulses
- Nonlinear effects in Compton back scattering limit laser energy at ~1J
- Pulse train structure of 2820 bunches is set by main linac.
- ~300ns bunch spacing in the main linac will be changed in the dumping ring in any design. 12 ns bunch spacing is selected to optimize linac acceleration gradient.
- Train of ~10 nC electron bunches is required to produce  $10^{12}$  polarized gammas per bunch. (~1  $\gamma$ -ray per 1 electron per laser IP)
- Reduction of charge in the bunches (stacking of the positrons) leads to increase in the average power of the laser and electron beams
- Conversion efficiency of polarized gammas into captured polarized positrons is assumed at ~1.5% and is subject of optimization.
- The size of the gamma beam on the conversion target is expected to be much smaller when compared to other schemes due to the compact design of the Compton backscattering region.
- Laser and drive linac are operated at 150Hz to optimize its performance. Train
  of 100 bunches is generated with 150Hz. 30 pulses are needed to form ~3000
  bunches of ILC beam, stored in the dumping ring.

## Polarized $\gamma$ beam generation

Parameter	Symbol	Single Shot Injection		Storage mode	Unit
Rep rate	$f_{rep}$	5		150	Hz
e- per bunch	$n_e$	8×10 <sup>10</sup>		8×10 <sup>10</sup>	
Bunches per pulse	$N_b$	2820		100	
Bunch Spacing	$ au_b$	6	3	12	ns
Beam current (ave./pulse)	$I_{\it beam}$	0.2/2	0.2/4	0.2/1	m <i>A/A</i>
Average e-beam power	P <sub>beam</sub>	1		1	MW
Number of laser IPs	N <sub>laser</sub>	30	15	5	
Laser pulse length	$ au_{laser}$	5			ps
Intra cavity energy	E <sub>laser</sub>	4 × 0.8	8x0.8	2x0.8	
Ave. laser power (5% losses)	P <sub>laser</sub>	30x0.4	15×0.7	5x0.7	kW
Size at focus	$\sigma_{laser}$	40		μ <b>m</b>	
Efficiency per laser IP	Ny/Ne-	~1			
Number of $\gamma$	Mγ	1.5×10 <sup>12</sup>			

# Ring or Linac? Stacking or No-stacking?

- RMS energy spread in 6 GeV Compton ring ~2% for CO<sub>2</sub> laser interaction with 4MW in synchrotron radiation. Difficult ring and very difficult laser (high repetition rate, average power, cavity stacking).
- Head on Compton back scattering will be realized in the Linac design (electron beam will pass through small halls in the mirrors.)
- Aperture requirements for the ring design dictate less efficient small angle Compton back scattering scheme.
- For scheme without accumulation the main issue is high current ~4A in macro pulse (requires short accelerator sections, more klystrons and longer linac or a ring to change bunch spacing from ~12ns to 3ns).
- The average beam power is increased with higher repetition rate required for the scheme with accumulation. It is 3MW for 150Hz. SC and NC linac structures can be used. Very difficult laser
- Simpler damping ring and laser system at 5Hz for the scheme without accumulation might offset linac complexity.



### Laser system for PPS

- Optical slicing and amplification of 5 ps CO<sub>2</sub>
  pulses has been demonstrated and utilized in
  routine ATF operation for user experiments.
- $CO_2$  oscillator and initial amplifiers are commercially available lasers from SDI and operate at rep. rate up to 500Hz.
- Final intracavity amplifiers shall operate at average power ~0.75 kW in non standard mode of operation.
- Another issue to be addressed by industry is fabrication of optical elements to withstand high intracavity laser power.

### Lasers from SDI

http://www.lightmachinery.com/SDI-CO2-lasers.html

WH20 WH100 WH350 WH500

9 -  $11\mu$ m, Line Tunable

20 Hz 100 Hz 350 Hz 500 Hz

1.5 J

Multimode

TEMoo, custom beam shapes, SLM

 $13 \times 13 \text{ mm}^2$ 

30 W 150 W 525 W 750 W

< 7 %

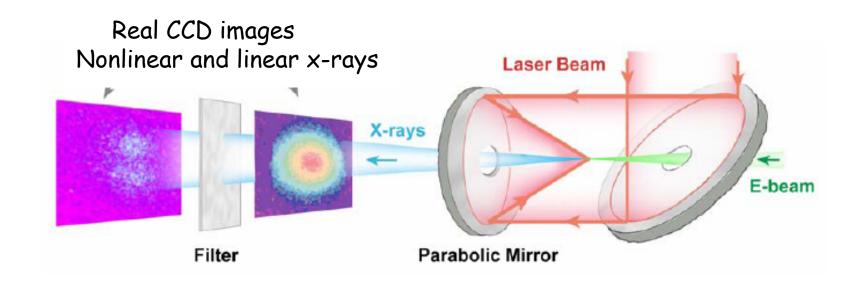
Wavelength
Continuous
Repetition Rate
Pulse Energy
Mode Type
Optional:
Beam Size

Average Power Power Stability



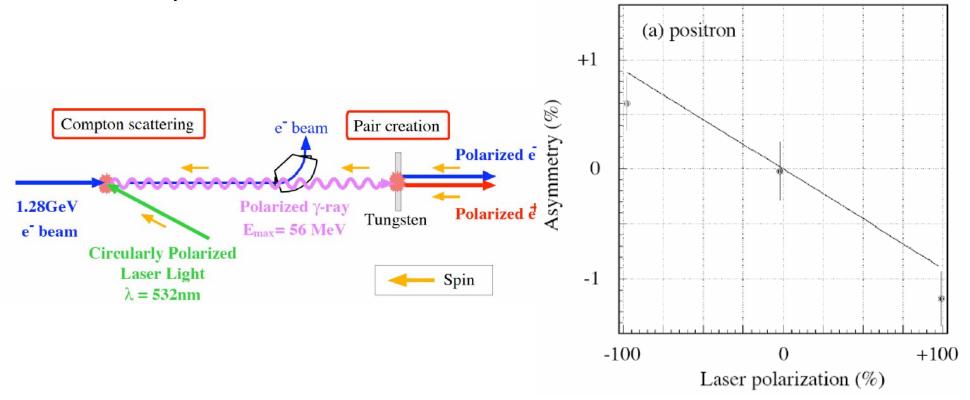
# Compton Experiment at Brookhaven ATF (record number of X-rays with 10 $\mu$ m laser)

- More then  $10^8$  of x-rays were generated in the experiment PR ST 2000.  $N_{\rm X}/N_{\rm e-}$  ~0.1.
- (0.35 as of April 2006- limited by laser/electron beams diagnostics)
- Interaction point with high power laser focus of ~30  $\mu m$  was tested.
- Nonlinear limit (more then one laser photon scattered from electron) was verified. PRL 2005.



# Compton Experiment at KEK ATF (polarized positrons with 532 nm laser)

- Experiment demonstrated beam of  $10^6\,\text{polarized}\,\gamma\text{-}$  rays (PRL 91/16, 2003)
- Experiment demonstrated 10<sup>4</sup> positron beam with 79% polarization level (KEK Preprint 2005-56, PRL 2005)



#### Laser R&D

- 1st year: (2 Post Doc + \$250K equipment)
  - Demonstrate slicing of a train of eight 5-ps CO2 pulses (based on existing ATF laser systems)
  - Simulations of the ILC laser system.
  - Design and purchase of custom CO2 amplifier ~5J/pulse, 150 Hz
  - Design of photocathode/slicing laser
- 2<sup>nd</sup> year: (2 Post Doc + \$700K equipment + room)
  - Dedicated YAG oscillator and amplifiers
  - Purchase of standard CO2 oscillator and amplifier @150 Hz
  - 8-pulse train amplification to 1J/pulse.
  - Delivery of custom CO2 amplifier ~5J/pulse, 150 Hz, 10 atm
- 3<sup>rd</sup> year (2 Post Doc + \$500K equipment)
  - Injection of 2-pulse train into interaction cavity and maintaining 100 intra cavity passes (total 200 pulses @ 1J/pulse, 150 Hz).
  - Intracavity laser/e-beam (60 MeV) interaction with production of trains of 100 6.5 keV x-ray pulses @ 6 Hz between trains with efficiency  $N_\gamma/N_{e^-} \sim 1$ .
- At the end of 3 year program we will have full scale prototype with one (out of five) interaction cavity @150Hz. The laser injection part will be fully functional.

- The accelerator part of PPS proposal is based on the existing technologies and design can be completed in about 1 year.
- 2nd and 3rd years of R&D will be focused on risk reduction

# Cost speculation to prioritize R&D areas

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    @5Hz, 3 ns (no storage, 2820 per pulse)

   - CO2 Laser system @5Hz
                                             ~10M$
   - 4Gev, 4A 5 Hz linac 10MV/m
                                             ~300M$
   - Damping ring (2.5 km)
                                             ~200M$
• @5Hz, 6ns (no storage, 2820 per pulse)
   - CO2 Laser system @5Hz
                                             ~15M$
   - 4Gev, 2A 5 Hz linac 15MV/m
                                             ~150M$
   - Damping ring (5 km)
                                             ~300M$

    @150Hz (beam storage: 30 pulses 100 bunches each)

   - CO2 Laser system @150Hz
                                              5-10M
   - 4GeV, 0.8A 150Hz linac 20MV/m
                                             ~100M$
   - Damping ring (2.5 km)
                                             ~200M$
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Optimization is needed!

### Conclusion

- We propose Polarized Positron Source based on Compton back scattering inside optical cavity of  $CO_2$  laser beam and 4 GeV e-beam produced by linac.
- The proposal requires high power picosecond CO2 laser mode of operation tested at ATF to generate 1 gamma per 1 electron per 1 laser IP.
- The proposal utilizes commercially available units for laser and accelerator systems.
- 3 year laser R&D is needed to verify laser operation in the non standard regime.
- CLIC beam needs are easily satisfied due to lower beam intensity requirement and same rep. rate.